A computational study on the variation of Bandgap due to native defects in non-stoichiometric NiO and Pd, Pt doping in stoichiometric NiO

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Abstract

This paper presents computational study of non-stoichiometric nickel oxide in a 32-cell NiO system to model and validate localized heating effects due to nanosecond laser irradiation. Variation in Bandgap of NiO is studied as a function of varying concentrations of native defects ranging from 0 to 25%. It is observed that there is a slight increase in the bandgap from 3.8eV for stoichiometric NiO to 3.86eV for Ni-rich NiO and to 3.95eV for O-rich NiO. It is hence deduced that the experimental laser irradiation leads to simultaneous reduction of Ni²⁺ ions and oxidation of NiO as the number of laser pulses increase. As well, a detailed study on the effects of doping nickel family elements, i.e. palladium (Pd) and platinum (Pt) in stoichiometric NiO is presented. A bandgap decrease from 3.8eV for pure NiO to 2.5eV for Pd-doping and 2eV for Pt-doping for varying doping concentrations ranging from 0-25% Pd, Pt respectively is observed.

1. Introduction

Transition metal oxides (TMOs) constitute an important section of semiconducting materials exhibiting a variety of electronic and magnetic properties that are observed with the nature of their outer d states. Point defects in TM oxides such as vacancies and interstitials play a crucial role in determining the behavior of such oxides. Nickel Oxide (NiO) is a classic example of the transition metal oxides (TMOs) that has presented significant challenges for an accurate theoretical description of their electronic structure. Due to the complicated nature of its electronic properties, NiO has received considerable attention from both experimentalists and theorists.
Density functional theory (DFT) study on undoped NiO was first reported in detail in [1], wherein, the electron correlations in the 3d shell of metal ions in nickel oxide were computed using a combination of local spin density approximation (LSDA) and unrestricted Hartree-Fock approximation (U) techniques. This method was able to calculate total energy of crystalline nickel oxide and validate the obtained results by measuring the electron energy loss spectra. The local-density approximation (LDA) plus Hubbard model were implemented in [2] to compute the insulating antiferromagnetic ground state of NiO and its optical properties. It is observed that charge transfer was a result of enhancement of O 2p character at the top of the valence state rather than Ni d-d LSDA-type band gap. In [3], an ab initio study of NiO at the Pd (100) surface was studied and observed that a Ni$_3$O$_4$ phase existed with rhombic distribution of Ni vacancies. A preferential formation due to surface reaction of O and NiO was shown to be thermodynamically possible along with some peculiar aspects resulting from a strong bond formation between Pd and O. In [4], magnetism of uniform amorphous NiO showed a disordered structure with a dominant antiferromagnetic coupling, an ordering temperature of 3 K, and a paramagnetic ordering temperature of -13 K. NiO clusters with a size of less than 1 nm indicated ferromagnetic interactions. The stability and magnetism associated with vacancy in NiO is studied using GGA+U in [5]. The role of oxygen vacancies and mechanism of oxide reduction were dealt with in [6] and the electronic structure of oxygen and nickel vacancies at the surface of NiO (100) was investigated in [7] using hybrid DFT calculations. General gradient approximation (GGA) technique was used to study the defect formation energies under different conditions and inducted magnetism by vacancies in [8]. The results indicated that the predominant defect is Ni vacancy under oxygen-rich condition and the most suitable ionization state varies with different fermi level.

The stoichiometric NiO is a Mott insulator with conductivity of $10^{-13}$ S/cm, while nonstoichiometric NiO$_x$ is a wide-band-gap p-type semiconductor. The p-type conductivity of NiO$_x$ originates from two positive charge compensation which favors Ni$^{2+}$ vacancies [8]. Several methods have been used for growing NiO films, including sputtering [9], [10]–[12], e-beam evaporation [13], [14], chemical and plasma-enhanced chemical vapor methods [15], [16], [17], pulsed laser deposition [18], spray pyrolysis [19], [20]. Among the above-mentioned techniques, sputtering is one of the preferred due to its industrial scalability. However, the composition and electrical conductivity of sputtered films are far from equilibrium [21], [22]. Lattice defects are
not well-defined in NiO films with high oxygen content [23]. From [25], [26], it is observed that high energy laser irradiation causes a change in the chemical composition as well as the electrical properties of NiO, but a thorough computational analysis hasn’t been presented till date. Due to its uncertain mechanism, nickel vacancy and/or interstitial oxygen are used to explain the electrical properties of the NiO films. To facilitate this study, density functional theory offers the right platform for defect analysis.

Also, recent studies indicate an enormous work in doped NiO to enhance room temperature ferromagnetism for multiferroic devices [27], supercapacitor applications [28] and resistive switching [29]. Dopants such Cu [29], Li [30] enhance the p-type conductivity of NiO films and have been studied extensively, both theoretically and experimentally. Doping NiO with metals in the nickel family, i.e. Palladium (Pd) and Platinum (Pt) have gained attention owing to their Electrochromic, supercapacitor and gas-sensing applications and studied extensively experimentally[31],[32],[33],[34],[35],[36],[37],[38], but no theoretical analysis has been investigated in knowing the vacancy and interstitial behavior in doped NiO. In this paper, we also study the effect of doping Pd and Pt on the bandgap of NiO by varying doping concentrations from 0 to 25% doping in a 32 cell NiO.

2. **Computational method**

All the computations are performed based on the generalized gradient (GGA) and local density approximations (LDA) to DFT using the Vienna ab initio simulation package (VASP)[39], [40]. A k-point density equivalent to 4 k-points in the irreducible part of the Brillouin zone resulted from the tests of convergence in the 32-atom primitive cell. The single particle wave functions are expanded in a plane-wave basis using a 420eV energy cutoff for LDA and 460eV for GGA. Full relaxation of ions is performed for undoped NiO to find the minimum energy of each configuration. The absolute minimum was in total energy was obtained by varying the lattice constant. The calculations for the density of states (DOS) were performed with Methfessel-Paxton scheme for the energy[41]. Computations of dopants (Pd, Pt) were performed by substituting Ni positions in the 32 cell NiO with varying doping concentrations ranging from 0-25%. Similarly, native defects (Ni, O) were introduced at interstitial sites in the
32 cell NiO with varying concentrations from 0-25%, i.e., introducing 0 to 8 Ni or O interstitials respectively.

3. Results and discussion

Pure nickel oxide belongs to the space group Fm-3m with the space number 225. The primitive cell of NiO consists of a Ni\textsubscript{16}O\textsubscript{16} unit of 32 atoms in a rock-salt structure. Positions of the 32 atom basis in this cell are obtained from International tables for crystallography. The N atoms forming the fcc lattice occupy the Wyckoff position 4a. For a crystal, whose lattice reacts as an elastic medium, the Vegard law is obeyed, i.e., change of the lattice constant is proportional to the concentration of the dopant and to the difference between ionic radii of the dopant and substituted host atom. Therefore, to examine the influence of doping on the lattice constant is examined, it is important to know the concentration of native defects.

3.1 Density of states (DOS)–excess Ni occupying interstitial sites in NiO

From the GGA calculations, Ni interstitials dominate under excess Ni conditions, as depicted in Figure 1(a-d), in agreement with the observed Ni deficiency and n-type behavior of NiO. The results show that O interstitials are generally unstable and that O vacancies are the lowest energy defects near the Fermi level. As a result, from [26], it is observed experimentally that, Ni-rich NiO is typically n-type semiconductor. There is also a slight increase in the bandgap for increasing % doping of excess of Ni in NiO system (figure 1(a-d)). Table 1 summarizes the extent of increase and it is comparable to the ellipsometric analysis established in [26].
The computational analysis, shown in Figure 2(a-d), reveals that Ni vacancies dominate under excess O conditions, which is usually the case with sputtered NiO films and is in agreement with the observed Ni deficiency and p-type behavior of NiO. From [26], it is observed experimentally that, O-rich NiO is typically p-type semiconductor. Table 2 depicts the increasing trend in bandgap with an increase in O concentration.

### 3.2. Density of states (DOS) – excess O occupying interstitial sites in NiO
Figure 2. Density of States for excess O in NiO (a) 3%, (b) 12%, (c) 18% and (d) 25% O.

Table 2. Bandgap of excess O in NiO with respect to % doping

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<th>% excess O</th>
<th>3</th>
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<th>18</th>
<th>25</th>
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<td>3.85</td>
<td>3.90</td>
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</table>

3.3. Density of states (DOS) - Pd as dopant occupying interstitial sites in NiO

Figure 3(a-d) presents DOS for 3-12 % doping of Pd in NiO. A band gap of 3.8eV is observed for 3 % Pd doping. As the doping increases, there is a decrease in the bandgap of Pd-doped NiO up to 12% doping. It is plausible to explain that the bandgap has negligible effect on doping up to 12% Pd because these Pd atoms occupy only interstitial sites in the 32-cell NiO system. Table 3 summarizes the bandgap versus % doping in Pd-NiO system.
Figure 3. Density of States for Pd-doped NiO (a) 3% (b) 6% (c) 9% and (d) 12% Pd.

Table 3. Bandgap of Pd-doped NiO with respect to % doping

<table>
<thead>
<tr>
<th>% Pd doping</th>
<th>3</th>
<th>6</th>
<th>9</th>
<th>12</th>
<th>15</th>
<th>18</th>
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<tbody>
<tr>
<td>Bandgap (eV)</td>
<td>3.80</td>
<td>3.75</td>
<td>3.50</td>
<td>3.20</td>
<td>2.95</td>
<td>2.80</td>
<td>2.70</td>
<td>2.50</td>
</tr>
</tbody>
</table>

For higher doping percentage of Pd in NiO (fig. 4(a-d)), there is a further decrease in the bandgap of Pd doped NiO from 2.95eV to 2.5eV. This arises from the Pd$^{2+}$ substituting Ni$^{2+}$ sites resulting in an increase in the lattice constant and overall volume of the cubic cell. The Pd atoms reorganize and stabilize the NiO units with increase in doping concentration. The nonstoichiometric phase of NiO goes through a phase of donating oxygen (i.e. electrons), thus keeping the Fermi level close to the valence band [32]. Hence, it can be deduced that Pd-NiO is p-type in nature.
3.4. Density of states (DOS) - Pt as dopant occupying interstitial sites in NiO

Density of States for various % doping of Pt in NiO is shown in Figure 5(a-d). A band gap of 2.5eV is observed for 3 % Pd doping. It can be observed that as the doping increases, there is a slight change in the bandgap of Pd-doped NiO upto 12 % doping. Due to the large size of Pt atom, there is some amount of distortion in the lattice arrangement resulting in a dominant Pt$^{3+}$ vacancy occupying the previously held Ni$^{2+}$ in the cubic lattice.
Figure 5. Density of States for Pt-doped NiO (a) 3% Pt, (b) 6% Pt, (c) 9% Pt and (d) 12% Pt.

For higher doping percentage of Pt in NiO, there is a further decrease in the bandgap of Pt doped NiO from 2.5 eV to 2.0 eV, as shown in Figure 6(a-d). This arises from the Pd$^{2+}$ substituting Ni$^{3+}$ sites resulting in an increase in the lattice constant and overall volume of the cubic cell. Table 4 summarizes the bandgap versus % doping in Pt-NiO system.
4. Conclusion

Bandgap calculations have been performed on nonstoichiometric NiO with excess native defects and it is observed that there is a slight increase in the bandgap of NiO. This study also validates that O-rich NiO is p-type in nature whereas, Ni-rich NiO is n-type. Also, doping NiO with nickel family elements i.e., Pd and Pt by varying the doping concentration from 0-25% is studied. It is observed that there is a decrease in bandgap from 3.8eV for pure NiO to 2.5eV
for 25% Pd doping. Similarly, there is a decrease in bandgap to 2eV for 25% Pt doping. The density of state calculations suggests that, both Pd- and Pt-doped NiO are p-type in nature.

Acknowledgements

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REFERENCES


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